UCSF May Submit 1 Application

Internal Deadline: 11:59 PM, Wednesday, July 05, 2023

PLEASE FORWARD THIS ANNOUNCEMENT TO ALL APPROPRIATE FACULTY AND RESEARCH ADMINISTRATORS


REQUEST FOR APPLICATIONS NUMBER: RFA-OH-22-001

PURPOSE:
• To solicit applications for funding Education and Resource Centers (ERCs) focused on occupational health, safety and research training, education and outreach.
• The overall objective of the National Institute for Occupational Safety and Health (NIOSH) is to provide an adequate supply of qualified personnel to carry out the purposes of the Occupational Safety and Health Act. The ERCs are one of the principal means for meeting this objective
• ERCs must provide high-quality graduate training in a minimum of three academic programs. At least two of the Academic Training Programs must be in the disciplines of Industrial Hygiene (IH), Occupational Health Nursing (OHN), Occupational Medicine (OM), or Occupational Safety (OS)

ELIGIBILITY:
• Any individual(s) with the skills, knowledge, and resources necessary to carry out the proposed research as the Program Director(s)/Principal Investigator(s) (PD(s)/PI(s)) is invited to work with their organization to develop an application for support. Individuals from underrepresented racial and ethnic groups as well as individuals with disabilities are always encouraged to apply.

BUDGET AND PROJECT PERIOD:
• Award Budget: $1.8M, each year in total costs for an ERC
• Project Period: 3 years
• UCSF is not eligible for renewal and therefore not eligible to apply for a longer project period

NUMBER OF APPLICATIONS UCSF MAY SUBMIT: 1

APPLICATION TYPES ALLOWED: AWARD TYPES ALLOWED: New, Renewal, Revision, Resubmission

DUE DATES:
• Internal: 11:59 PM, Wednesday, July 05, 2023. If multiple groups submit an LOI, an additional pre-application will be due Tuesday, July 25, 2023
• PIs submit directly to the LSP; RMS does not get involved unless and until you are nominated.
• Sponsor: Monday, October 24, 2023

Submit the attached Letter of Intent (LOI) by 11:59 PM, Wednesday, July 05, 2023 to: limitedsubmissions@ucsf.edu
To qualify for UCSF Limited Submissions Program opportunities, applicants must have a paid UCSF appointment either at the time of application or anticipated by the time of award.

The LSP is a selection process, not an award process. As the LSP is under significant time constraints, all reviewer feedback is optional. We encourage you to seek other avenues for proposal feedback.

For information on all current LSOs, please visit: [http://rdo.ucsf.edu/limited-submission-program-lsp](http://rdo.ucsf.edu/limited-submission-program-lsp)

Sent by Connie D’Aura on behalf of the Limited Submissions Program (LSP) within the Research Development Office (RDO).